

Under the Paperwork Reduction Action of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

| Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i> | | | | Application Number | | Filed Herewith | |
|---|--|---|----|--|---|--|----------------|
| | | | | Filing Date | | 11/19/2003 | |
| | | | | First Named Inventor: | | Thomas Hantschel et al. | |
| | | | | Examiner name: R. Raevis (Parent case) | | GROUP: 2856 (Parent case) | |
| Sheet | 1 | of | 1 | Attorney Docket Number | | A2083D (XC-019-2D) | |
| U.S. PUBLISHED PATENT APPLICATIONS | | | | | | | |
| Examiner Initials* | Cited No. ¹ | U.S. Patent Document Number Kind Code ² (if known) | | Name of Patentee or Applicant of Cited Document | Date of Publication of Cited Document MM-DD-YYYY | Pages, Columns, Lines Where Relevant Info. Appear | |
| RP | A1 | 2002/0040884 | A1 | Hantschel et al. | 04-11-2002 | | |
| RP | A2 | 2002/0047091 | A1 | Hantschel et al. | 04-25-2002 | | |
| RP | A3 | 2002/0079445 | A1 | Hantschel et al. | 06-27-2002 | | |
| U.S. PATENT DOCUMENTS | | | | | | | |
| Examiner Initials* | Cited No. ¹ | U.S. Patent Document Number Kind Code ² (if known) | | Name of Patentee or Applicant of Cited Document | Date of Publication of Cited Document MM-DD-YYYY | Pages, Columns, Lines Where Relevant Info. Appear | |
| RP | A4 | 3842189 | | Southgate | 10/15/1974 | | |
| ↓ | A5 | 5399232 | | Albrecht et al. | 03/21/1995 | | |
| ↓ | A6 | 5613861 | | Smith et al. | 03/25/1997 | | |
| FOREIGN PATENT DOCUMENTS | | | | | | | |
| Examiner Initials* | Cited No. ¹ | Foreign Patent Document Office ³ Number ⁴ Kind Code ⁵ (if known) | | Name of Patentee or Applicant of Cited Document | Date of Publication of Cited Document MM-DD-YYYY | Pages, Columns, Lines Where Relevant Info. Appear | T ⁶ |
| | | | | | | | |
| OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) | | | | | | | |
| | "Nanostructure patterns written in polycarbonate by a bent optical fiber probe", pages 2299-2300 | | | | | | |
| | | | | | | | |
| | | | | | | | |
| EXAMINER | | | | DATE CONSIDERED | | | |

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.